OIPE
JUN 19 2006
IAP3
PATENT & TRADEMARK OFFICE

AME. I
7/27/06

Docket No.: 3430-0193P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jeong-Rok KIM et al.

Application No.: 10/681,140

Confirmation No.: 6455

Filed: October 9, 2003

Art Unit: 2871

For: SPUTTER FOR DESPOSITION OF METAL LAYER AND FABRICATING METHOD OF LIQUID CRYSTAL DISPLAY DEVICE USING THE SAME

Examiner: H. L. Ngo

Entered
RCE
J. McMillan
8/1/06

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Examiner's final Office Action dated March 16, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Claims; and

Remarks.

06/19/2006 SZEWDIE1 00000086 10681140
01 FC:1202 200.00 OP

EHC/GH/cl